

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1	"20040079962" and probe	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/01 16:11
L2	330	dc near2 plasma near10 microwave	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/01 16:11
L3	125	dc near2 plasma near10 microwave near10 (cvd or chemical near2 vapor near2 deposit\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/01 16:11
L4	87	dc near2 plasma near10 microwave near10 (cvd or chemical near2 vapor near2 deposit\$4) and @py<"2003"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/01 16:12
L5	8	dc near2 plasma near10 microwave near10 (cvd or chemical near2 vapor near2 deposit\$4) and @py<"2003" and nanotube	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/01 16:16
L6	0	"20020163079".pn. and microwave	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/01 17:19
L7	45	(akimitsu near2 hatta or hiroaki near2 yoshimura or keiichi near2 ishimoto or hiroaki near2 kanakusa or shinichi near2 kawagoe).in.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/01 17:20
S1	3	acircular near10 (si or silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/19 21:12
S2	609	acicular near10 (si or silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/19 16:15

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S3	3	acicular near10 (si or silicon) near16 (radius near5 (curv\$7 or curvat\$6))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/19 16:17
S4	2	"2002220300"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/19 16:18
S5	48	(curv\$5 or curvatur\$6) near15 (acicular or rod or needle) near10 (si or silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/19 16:18
S6	609	acicular near10 (si or silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/15 16:41
S7	28	acicular near10 (si or silicon) near10 (carbon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/15 16:42
S8	147	acicular near10 (si or silicon) near10 crystal\$7	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/15 17:12
S9	105	(si or silicon) near10 crystal\$7 near15 (needle or whisker or dendrite or acicular) near15 (carbon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/15 17:13
S10	1	(si or silicon) near10 crystal\$7 near15 (needle or whisker or dendrite or acicular) near15 (carbon) near5 coat\$6	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/16 10:48
S11	2	"20020129761"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/16 10:56
S12	64	acicular and (vapor near2 liquid near2 solid or vls)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/16 10:51

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S13	8	acicular same (vapor near2 liquid near2 solid or vls)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/16 10:51
S14	287	(nanowire or quantum near2 wire or nanofiber or nanotube) near10 (si or silicon) near15 nm	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/16 10:57
S15	41	(nanowire or quantum near2 wire or nanofiber or nanotube) near10 (si or silicon) near15 nm and vls	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/16 11:11
S16	2	"20050244324"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/16 11:13
S17	382	(si or silicon) near10 (nano\$5) near10 (tip or cone or conical or acicular)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/16 11:14
S18	125	(si or silicon) near10 (nano\$5) near10 (tip or cone or conical or acicular) near15 (sharp\$5 or curv\$5 or radius or point)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/16 11:15
S19	2394	(acicular or cone or conical) near10 (si or silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/19 21:12
S20	43	(acicular or cone or conical) near10 (si or silicon) near10 nm	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/19 21:18
S21	70	(si or silicon) near5 probe near10 carbon	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/19 21:27
S22	232	(si or silicon) near5 probe near10 (afm or atomic near2 force)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/19 21:27

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S23	0	(si or silicon) near5 probe near10 (afm or atomic near2 force) and (plasma near2 cvd near10 silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/19 21:28
S24	184	(vls or vapor near2 liquid near2 solid) same plasma	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/20 12:53
S25	61	(vls or vapor near2 liquid near2 solid) near15 plasma	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/20 12:53
S26	2	(vls or vapor near2 liquid near2 solid) near15 plasma near10 (si or silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/20 12:54
S27	100	plasma near10 (si or silicon) near10 (probe or nanowire or nanotube)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/20 12:59
S28	2	"5976957".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/20 13:01
S29	1	"5976957".pn. and plasma	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/20 13:01
S30	0	(si or silicon) near2 quantum near2 wire near15 plasma	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/20 13:01
S31	0	(si or silicon) near2 quantum near2 wire same plasma	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/20 13:01
S32	44	(si or silicon) near10 wire near15 (nm or nano or nanometer) same plasma	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/20 13:10

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S33	158	nanotube near16 plasma near2 cvd	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/20 13:10
S34	3	nanotube near16 plasma near2 cvd near19 (si or silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/20 13:23
S35	11	"1192637"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/20 13:24
S36	5	"200103158"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/20 13:24
S37	64	(fe or iron) near10 catalyst same plasma near2 (cvd or chemical near2 vapor near2 deposit\$5)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/26 11:39
S38	2	"20020024279"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/26 11:19
S39	2	"20020024279" and (si or silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/26 11:25
S40	64	"6277318 "	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/26 11:25
S41	2	"6277318".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/26 11:26
S42	49	(fe or iron) near10 catalyst same plasma near2 (cvd or chemical near2 vapor near2 deposit\$5) and (si or silicon) near5 (substrate or wafer)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/26 11:45

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S43	14	(fe or iron) near10 catalyst same plasma near2 (cvd or chemical near2 vapor near2 deposit\$5) same (si or silicon) near5 (substrate or wafer)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/26 11:41
S44	54	(fe or iron) near10 catalyst same plasma near2 (cvd or chemical near2 vapor near2 deposit\$5) same (nano\$6 or micro\$5)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/26 14:24
S45	39	(fe or iron) near10 catalyst same plasma near2 (cvd or chemical near2 vapor near2 deposit\$5) same (nano\$6 or micro\$5) and (si or silicon) near5 (substrate or wafer)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/26 15:04
S46	0	afm near10 (si or silicon) near15 probe near10 (n\$1type)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/26 15:11
S47	63	(si or silicon) near15 probe near10 (n\$1type)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/26 15:12
S48	23	(si or silicon) near15 probe near10 (n\$1type) and @py<"2003"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/02/26 15:12